



Investigation on the Superconducting Properties of YGBCO/STO/YGBCO Tri-layer

Yanjie Yao, Linfei Liu, Xiang Wu, Saidan Lu, Wei Wang, Tong Zheng, Shunfan Liu, Yijie Li*
School of Physics and Astronomy, Shanghai Jiao Tong University

4MP5-10

Introduction

For applications in electrical equipment and mass production, high critical current density (J_c) is required. Unfortunately, J_c decreases with increasing YBCO layer thickness in many cases. Some groups tried slowing down the decrease tendency, but when the thickness of the superconducting layer is over 2 μm , the decrease is still obvious.

Superconductor/insulator/superconductor tri-layer structure can effectively inhibit thickness effect. In former studies, STO, LaAlO_3 , CeO_2 and NdAlO_3 were used as inter-layer materials. Among these materials, STO films represent a promising candidate due to their good chemical stability and small lattice mismatch between YBCO and STO.

Usually, the inter-layer is very thin to match the short coherent length of YBCO along the c-axis direction. And the tri-layer structure is usually prepared symmetrically, which means the thicknesses of the bottom-layer and upper-layer are the same. Former work often focus on the influence of inter-layer on the whole structure.

Motivation

$\text{Y}_{0.5}\text{Gd}_{0.5}\text{Ba}_2\text{Cu}_3\text{O}_{7-\delta}$ as superconducting layer

$\leftarrow\leftarrow T_c > 77\text{ K}$

CeO_2 buffered substrate

$\leftarrow\leftarrow$

High quality template for subsequent deposition of YGBCO films, lattice mismatch -0.52%

Tri-layer structure

$\leftarrow\leftarrow$

To inhibit thickness effect

80 nm STO inter-layer

$\leftarrow\leftarrow$

Former experiment

Asymmetrically

$\leftarrow\leftarrow$

Bottom-layer may have influence on the whole sample's superconducting property

Pulsed Laser Deposition (PLD)

$\leftarrow\leftarrow$

High deposition rate and capability of stoichiometric transfer materials from target to substrate

Method

Structure of samples

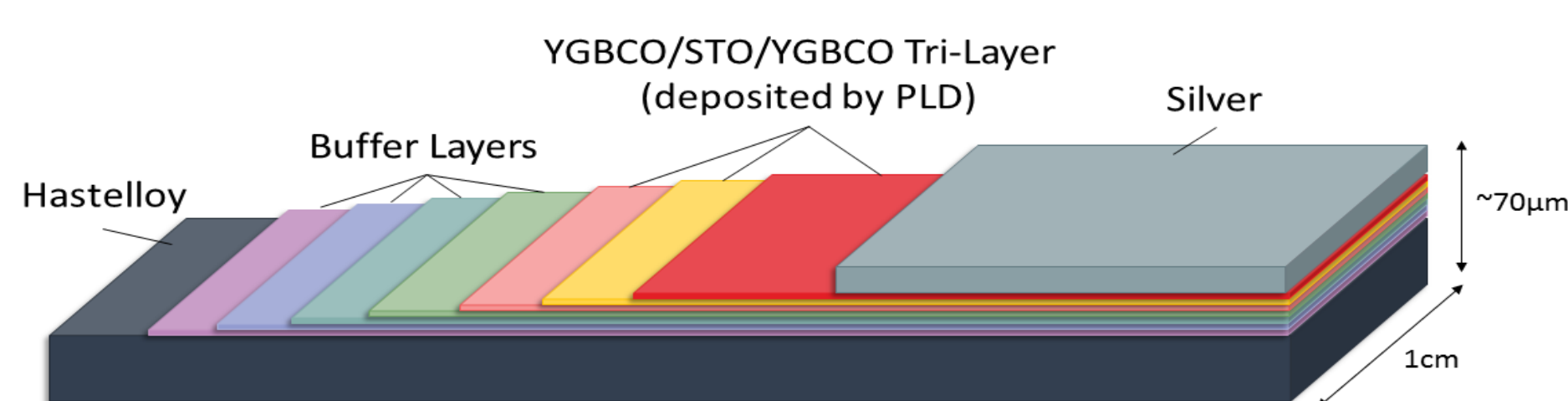


Fig. Basic structure of YGBCO coated conductor.

Pulsed Laser Deposition (PLD) system

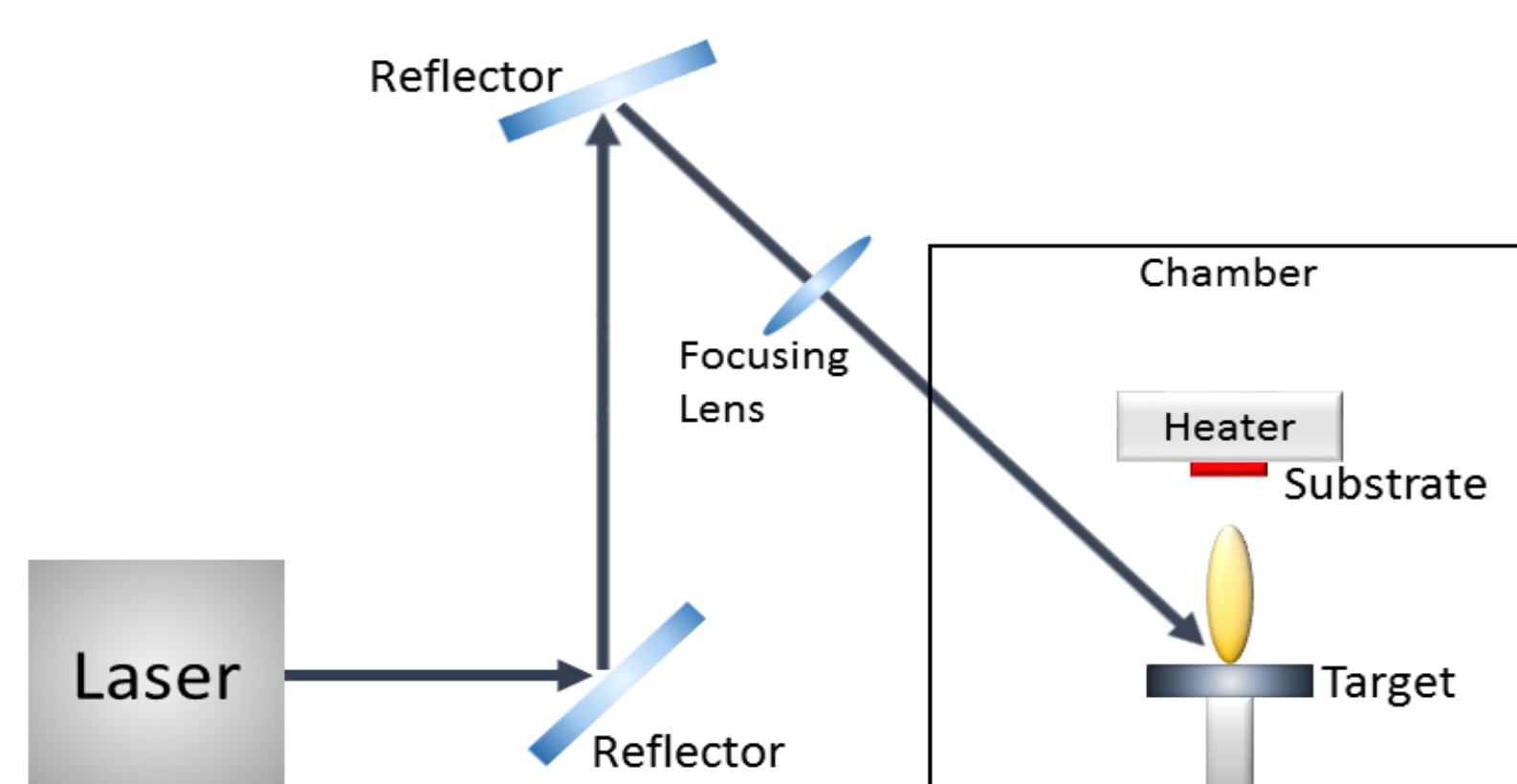


Fig.2 Sketch of the pulsed laser deposition system.

Experimental parameters:

- ✓ KrF excimer laser wavelength of 248 nm
- ✓ Laser power density $P_L = 1.0\text{ J/cm}^2$
- ✓ Incident angle between the laser beam and the target surface of 45°
- ✓ Distance between the substrate and the target of 4 cm.
- ✓ Laser repetition frequency of 160 Hz
- ✓ Oxygen partial pressure $P_O = 200\text{ mTorr}$

Detail information of samples

TABLE I

THE DETAILS OF THICKNESS IN DIFFERENT SAMPLES

Label	Total thickness of YGBCO (nm)	Bottom YGBCO layer (nm)	Upper YGBCO layer (nm)
S1	720	240	480
S2	720	480	240

When depositing the tri-layer structure, a multi-step deposition process was used, in which the thickness of the superconducting layer was increased by additional deposition cycles. In each standard cycle, the thickness of the deposited YGBCO layer was approximately 240 nm.

Hence, the deposition of the tri-layer structure in S1 consisted of one standard cycle as the bottom-layer, and two standard cycles as the upper-layer, while S2 had an opposite deposition process.

The thicknesses of the whole YGBCO superconducting layer of the two samples were both 720 nm. The thickness of the STO inter-layer was 80 nm, based on former experiment results.

Results and Discussion

Microstructure analysis

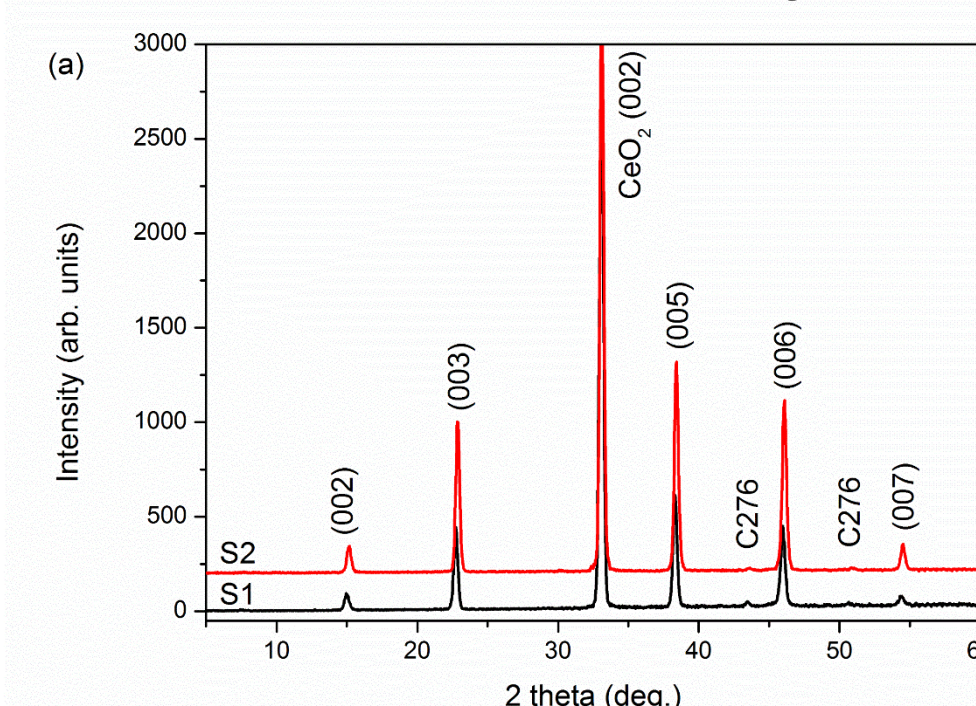


Fig. XRD patterns of the bottom-layer of the samples. (a) θ -2 θ scans of the samples; (b) magnification of YGBCO (005) peak.

C - axis orientation

Peak shift

Internal residual stress

Possible growth model

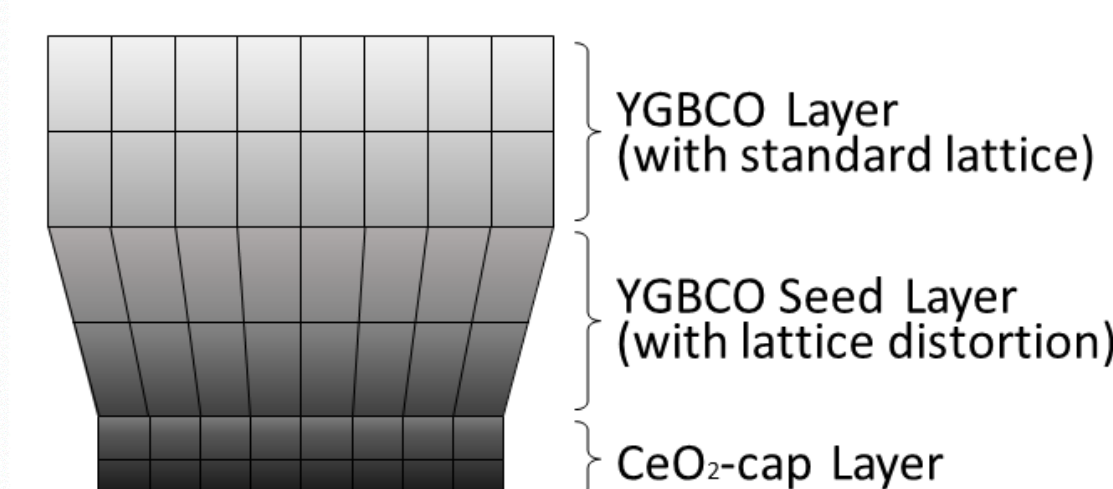


Fig. Schematic diagram of possible growth model for bottom layers in different thickness.

